



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Takanori SAITO, et al.) Confirmation No.: 4029
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U.S. Serial No. : 10/551,033)
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Filed : September 27, 2005)
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Examiner : Gregory A. Wilson) Group Art Unit: 3749
For : THERMAL PROCESSING METHOD AND
THERMAL PROCESSING UNIT

FIFTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement (IDS) and Citation Form (PTO-1449) are submitted with a Request for Continued Examination (RCE). This IDS is being filed to submit four (4) additional documents to the U. S. Patent and Trademark Office (USPTO), which documents were cited in an European Search Report.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

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